



PATENT

Atty. Dkt. No. AMAT/5750/CPI/LB/PJS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Miyanaaga, et al.

Serial No.: 10/045,746

Confirmation No.: 9682

Filed: October 26, 2001

For: Cleaning Method for Vapor Phase
Deposition Apparatus, and Vapor
Phase Deposition Apparatus

Group Art Unit: 1746

Examiner: Andrew McAleavey

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING
37 CFR 1.8I hereby certify that this correspondence is being deposited on
January 28, 2005, with the United States Postal Service as
First Class Mail in an envelope addressed to: Mail Stop
Amendment, Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450.1/28/05
Date[Signature]
Signature

RESPONSE TO OFFICE ACTION DATED SEPTEMBER 29, 2004

In response to the Office Action dated September 29, 2004, having an extended statutory period for response set to expire on January 29, 2005, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5750/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Specification begin on page 2 of this paper. **Amendments to the Claims** are reflected in the listing of claims which begins on page 4 of this paper. **Remarks** begin on page 6 of this paper.